

IN THE CLAIMS:

Please amend the claims as shown.

1 - 3. (cancelled).

4. (currently amended) The method as claimed in claim ~~1~~ 9, wherein the focal spot produces a molten area with a substantially linear, elliptical or rectangular geometry.

5. (currently amended) A method for producing monocrystalline structures, components or workpieces on substrates, comprising:

providing a monocrystalline layer;

melting a surface of the monocrystalline layer by an energy input of an energy source by a focal spot of the energy source having a geometry with a width sufficiently wide to melt a desired width of the surface to be melted and a length in a direction of movement of the focal spot transverse to the width that is less than the width;

advancing the focal spot in a single continuous movement in the direction transverse to the width only;

controlling a temperature of the melted surface by controlling the energy source;

feeding material to the melted surface; and

melting the fed material completely, whereby the molten fed material is introduced into the monocrystalline layer to solidify;

~~The method as claimed in claim 1,~~ wherein the width of the focal spot is changed during operation in response to a sensed width of the surface to be melted.

6. (currently amended) A method for producing monocrystalline structures, components or workpieces on substrates, comprising:

providing a monocrystalline layer;

melting a surface of the monocrystalline layer by an energy input of an energy source by a focal spot of the energy source having a geometry with a width sufficiently wide to melt a desired width of the surface to be melted and a length in a direction of movement of the focal spot transverse to the width that is less than the width;

advancing the focal spot in a single continuous movement in the direction transverse to the width only;

controlling a temperature of the melted surface by controlling the energy source;

feeding material to the melted surface; and

melting the fed material completely, whereby the molten fed material is introduced into the monocrystalline layer to solidify;

~~The method as claimed in claim 1,~~ wherein the focal spot has profile ends, and the intensity of the energy input is increased at the profile ends as compared with the middle area of the focal spot.

7. (cancelled).

8. (previously presented) The method as claimed in claim 15, wherein the temperature of the focal spot of the energy source is controlled by an optical system.

9. (currently amended) A method for producing monocrystalline structures, components or workpieces on substrates, comprising:

providing a monocrystalline layer;

melting a surface of the monocrystalline layer by an energy input of an energy source by a focal spot of the energy source having a geometry with a width sufficiently wide to melt a desired width of the surface to be melted and a length in a direction of movement of the focal spot transverse to the width that is less than the width;

advancing the focal spot in a single continuous movement in the direction transverse to the width only;

controlling a temperature of the melted surface by controlling the energy source;

feeding material to the melted surface; and

melting the fed material completely, whereby the molten fed material is introduced into the monocrystalline layer to solidify;

~~The method as claimed in claim 1,~~ further comprising:

moving the focal spot over the substrate in a direction of advancement wherein the substrate has an area to which material is added; and

adapting the focal spot to the geometry of the area such that the width of the focal spot is adapted to a width of the area transversely in relation to the direction of advancement.

10. (cancelled).

11. (currently amended) The method as claimed in claim—1_5, wherein the monocrystalline structures, components or workpieces are produced from metal superalloys.

12. (currently amended) A method for producing monocrystalline structures, components or workpieces on substrates, comprising:
providing a monocrystalline layer;
melting a surface of the monocrystalline layer by an energy input of an energy source by a focal spot of the energy source having a geometry with a width sufficiently wide to melt a desired width of the surface to be melted and a length in a direction of movement of the focal spot transverse to the width that is less than the width;
advancing the focal spot in a single continuous movement in the direction transverse to the width only;
controlling a temperature of the melted surface by controlling the energy source;
feeding material to the melted surface; and
melting the fed material completely, whereby the molten fed material is introduced into the monocrystalline layer to solidify;
wherein the energy input takes place by a laser;
~~The method as claimed in claim 2,~~ further comprising:
moving the focal spot over the substrate in a direction of
advancement wherein the substrate has an area to which material is added; and
adapting the focal spot to the geometry of the area such that the width of the focal spot is adapted to a width of the area transversely in relation to the direction of advancement.

13. (currently amended) A method for producing monocrystalline structures, components or workpieces on substrates, comprising:

providing a monocrystalline layer;

melting a surface of the monocrystalline layer by an energy input of an energy source by a focal spot of the energy source having a geometry with a width sufficiently wide to melt a desired width of the surface to be melted and a length in a direction of movement of the focal spot transverse to the width that is less than the width;

advancing the focal spot in a single continuous movement in the direction transverse to the width only;

controlling a temperature of the melted surface by controlling the energy source;

feeding material to the melted surface; and

melting the fed material completely, whereby the molten fed material is introduced into the monocrystalline layer to solidify;

wherein the energy input takes place by electron beams;

~~The method as claimed in claim 3,~~ further comprising:

moving the focal spot over the substrate in a direction of

advancement wherein the substrate has an area to which material is added; and

adapting the focal spot to the geometry of the area such that the width of the focal spot is adapted to a width of the area transversely in relation to the direction of advancement.

14. (currently amended) The method as claimed in claim ~~4~~ 5, wherein the substrate having a monocrystalline structure or monocrystalline structures.

15. (previously presented) A method for producing monocrystalline structures, components or workpieces on substrates comprising:

providing epitaxial growth;

melting a surface of the component by an energy input of an energy source by a focal spot of the energy source, the focal spot having a geometry with a width and a length in a direction of movement of the focal spot transverse to the width that is less than the width;

controlling a power intensity at opposed ends of the width of the focal spot to be greater than a power intensity in a central area of the width of the focal spot;

feeding material to a molten area; and

melting the fed material with the surface, whereby the molten material is introduced into the monocrystalline structure to solidify.

16. (previously presented) The method as claimed in claim 15, wherein the energy input takes place by a laser.

17. (previously presented) The method as claimed in claim 15, wherein the energy input takes place by electron beams.

18. (previously presented) The method as claimed in claim 15, wherein the focal spot produces a molten area with a substantially linear, elliptical or rectangular geometry.

19. (previously presented) The method as claimed in claim 15, wherein the monocrystalline structures, components or workpieces are produced from metal superalloys.

20. (previously presented) The method as claimed in claim 15, wherein the substrate having a monocrystalline structure or monocrystalline structures.

21. (previously presented) The method as claimed in claim 15, wherein the width of the focal spot is controlled so that a complete pass over a surface to be treated takes place in a single continuous advancing movement.

22. (cancelled).

23. (new) The method as claimed in claim 4, wherein the focal spot produces a molten area with a substantially rectangular geometry.